

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 3729**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshihiro KONDO

Group Art Unit: 3729

Application No.: 10/508,335

Examiner: T. NGUYEN

Filed: September 20, 2004

Docket No.: 121101

For: WORKING SYSTEM FOR CIRCUIT SUBSTRATE

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the July 11, 2007 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**